



Docket No.: 060188-0766

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Taiji NODA : Confirmation Number: 2607
Application No.: 10/775,122 : Group Art Unit: 2812
Filed: February 11, 2004 : Examiner: LEE, Cheung
: For: SEMICONDUCTOR DEVICE AND FABRICATION METHOD THEREFOR

INFORMATION DISCLOSURE STATEMENT

Mail Stop Information Disclosure Statement
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed more than three months after the U.S. filing date AND after the mailing date of the first Office Action on the merits, but before the mailing date of a Final Rejection or Notice of Allowance.

Please charge the amount of \$180.00 in payment of the fee under 37 C.F.R. 1.17(p).

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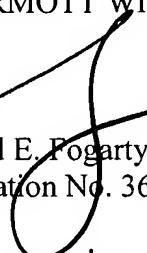
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Respectfully submitted,

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SHEET 1 OF 1

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.